

Summary

Lasers focused on the macro- and micro-world	10
Applications of laser-induced breakdown spectroscopy – LIBS	11
Laser Raman spectroscopy	13
Optical micromanipulation techniques	15
Special Technologies	18
Electron beam welding	19
Vacuum brazing and annealing	21
Design and manufacture of feedthroughs	22
Thin layers deposited by magnetron sputtering and their dynamic impact testing	23
Electron microscopy	24
High resolution scanning electron microscopy with analytics techniques	27
Scanning microscopy with slow electrons	29
Elektron mikroskopy of biological and sensitive samples	32
Environmental scanning electron microscopy and detection systems	33
Measurement of local mass-thickness of thin samples and mass of individual nanoparticles using SEM	36
Electron microscopy under ultrahigh vacuum conditions	37
New imaging methods of electron microscopy	39
Cryogenics and Superconductivity	40
Low temperature thermometry	41
Design and realisation of cryogenic systems	42
Determination of thermal-radiation properties of materials	43
Vacuum technique	44
Stationary magnetic fields	44
Consulting and training courses on safety in cryogenics	44
Lasers for measurement and metrology	46
Lasers with high coherence for measuring purposes	47
High-power ECL lasers	49
Laser etalons of optical frequencies	49
Absorption cells for spectroscopy and etalons of optical frequencies	52
Laser interferometric measuring systems	53
Deposition of interference coatings by electron beam evaporation and spectrophotometric measurement of spectral reflectance and transmittance	55
Special electronics and software	57
Electron beam lithography	58
E-beam pattern generator	59
E-beam lithography technology	60
Optical diffractive structures	61
Advanced high power laser technologies	62
Advanced high power laser technologies	63
Measurement and data processing in medicine	66
Software – methodology & processing	68
Data acquisition systems	69
Experimental devices for measurement of biomedical signals	69
Nuclear magnetic resonance	72
Imaging and data analysis	74
Application fields	75